

Supporting Information

Incorporation of NiO into SiO₂, TiO₂, Al₂O₃, and Na_{4.2}Ca_{2.8}(Si₆O₁₈) Matrices: Medium Effect on the Optical Properties and Catalytic Degradation of Methylene Blue

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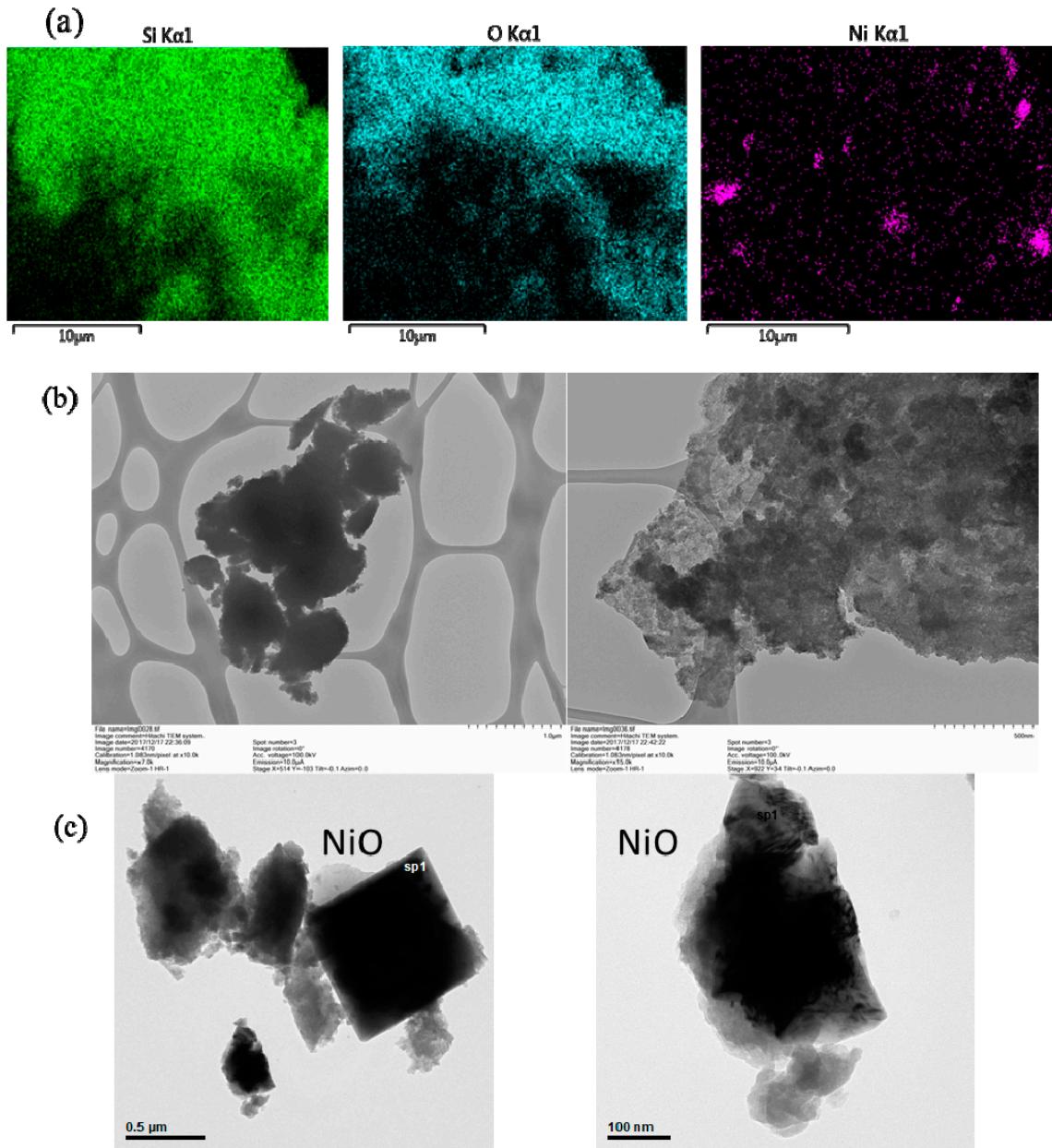


Figure S1. (a) SEM-EDS mapping by element and (b) TEM images and (c) HRTEM image of NiO from the PS-co-4-PVP·(NiCl₂)_x //SiO₂ precursor.

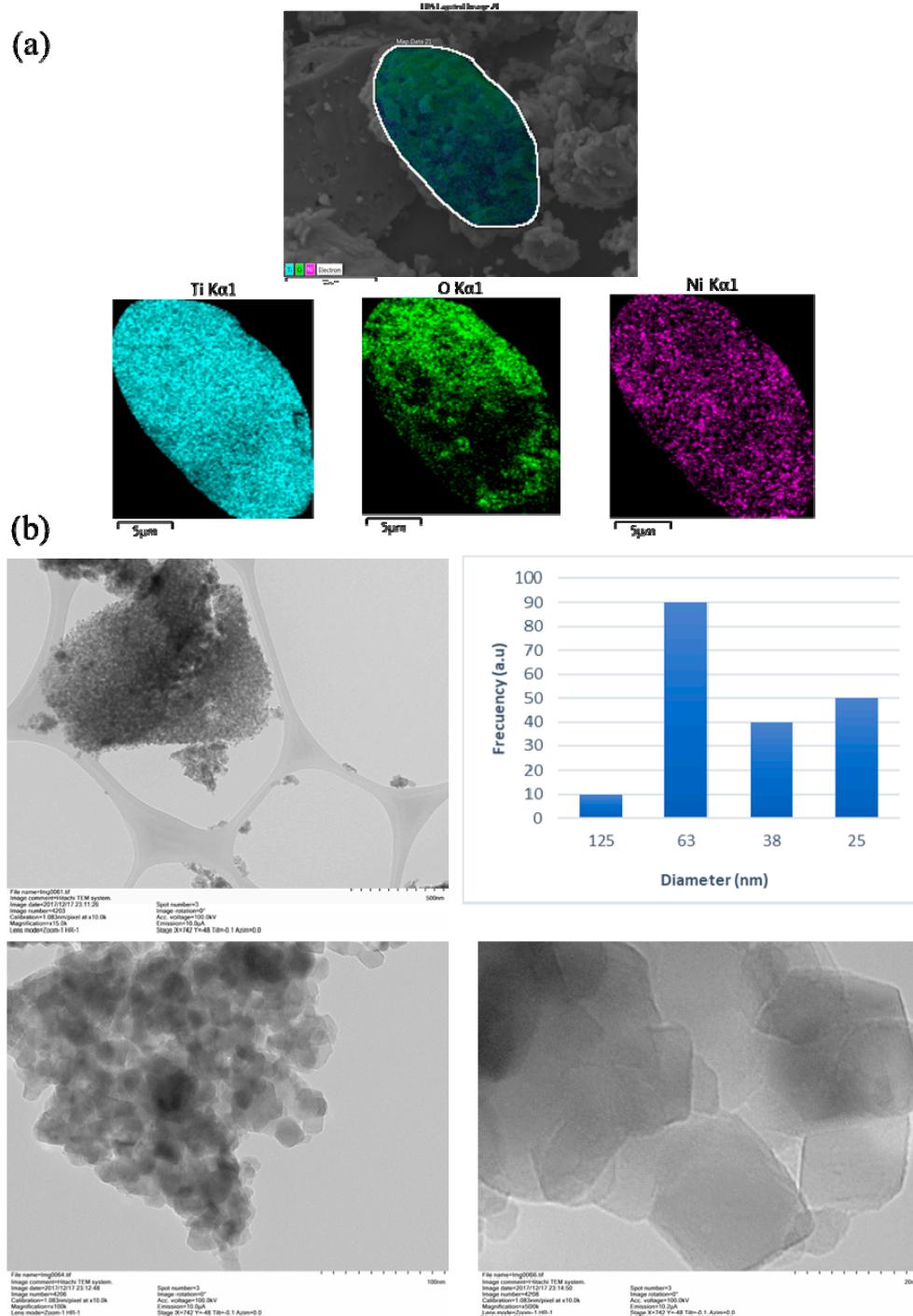


Figure S2. (a) SEM-EDS mapping by element from the PS-co-4-PVP-(NiCl₂)n//TiO₂ precursor and (b) TEM images and its histogram of the pyrolytic product from the PS-co-4-PVP-(NiCl₂)n//TiO₂ precursor.

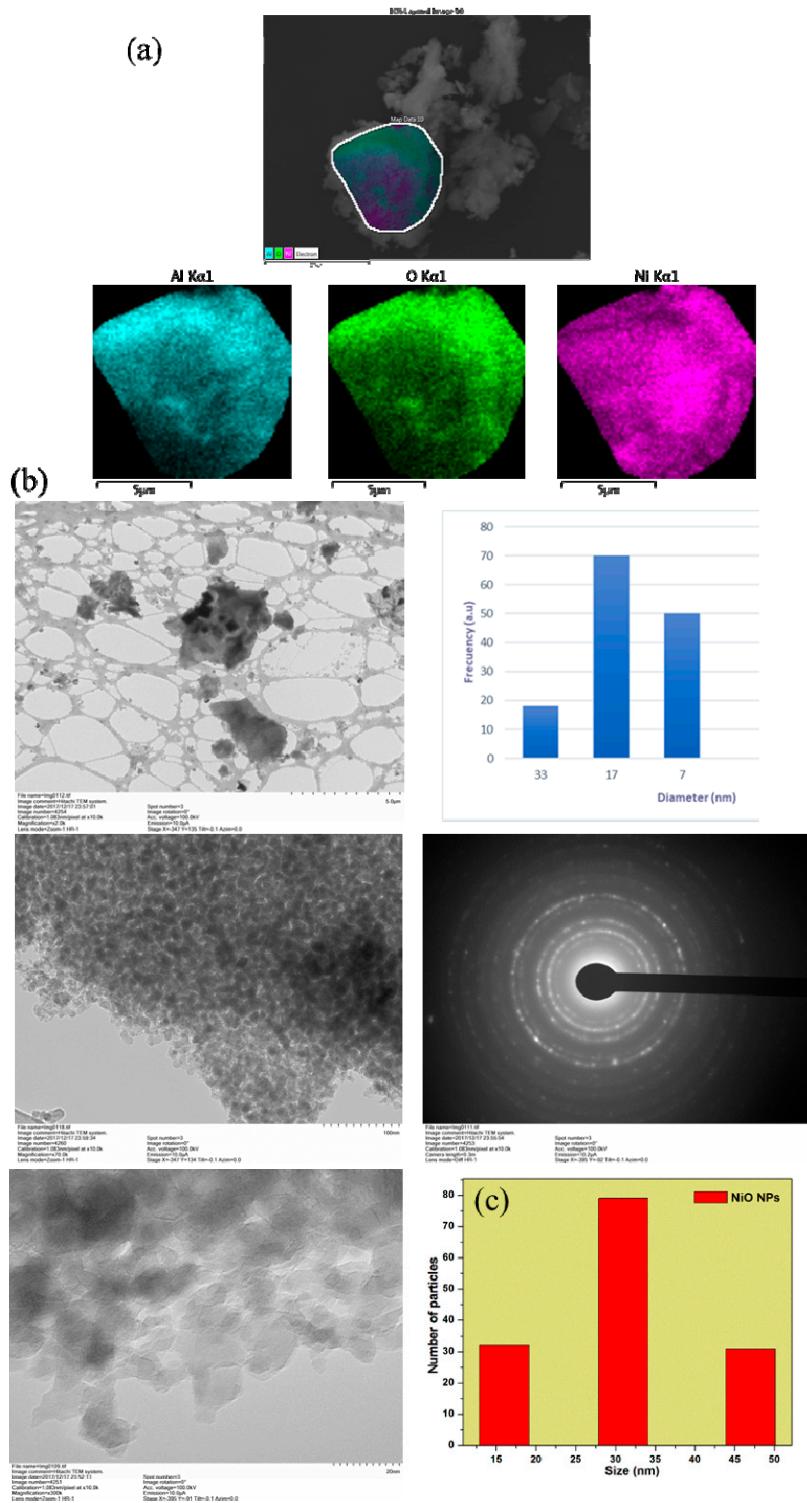


Figure S3. (a) SEM-EDS mapping by element and (b) TEM images, Histogram and electron diffractions, of the pyrolytic product from the precursor PS-co-4-PVP-(NiCl₂)n_x //Al₂O₃ and (c) Histogram of TEM image of NiO from Chitosan-(NiCl₂)n_x //Al₂O₃ precursor .

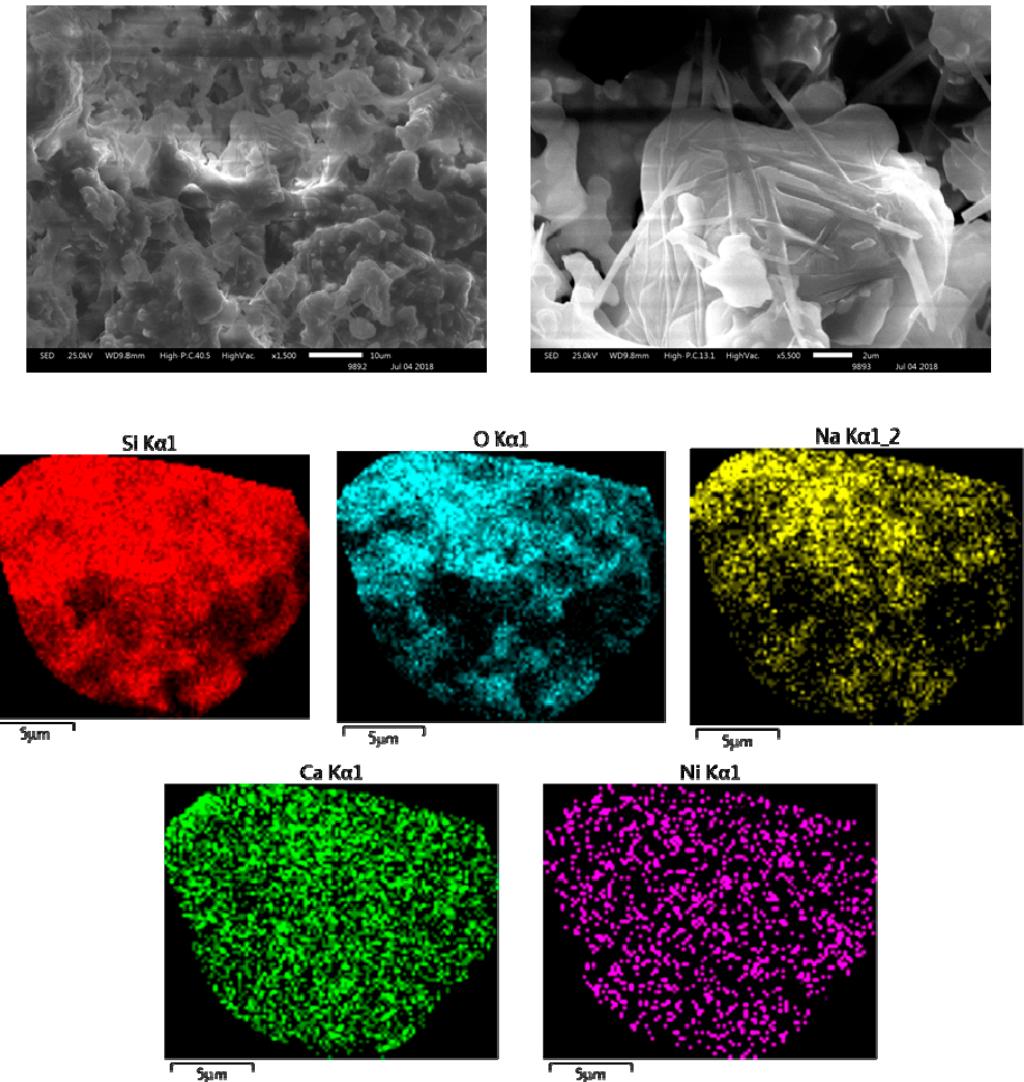


Figure S4. SEM image and EDS mapping analysis for the composite NiO/Na_{4.2}Ca_{2.8}(Si₆O₁₈) from the PS-co-4-PVP-(NiCl₂)_n//SiO₂·CaO·Na₂O precursor.

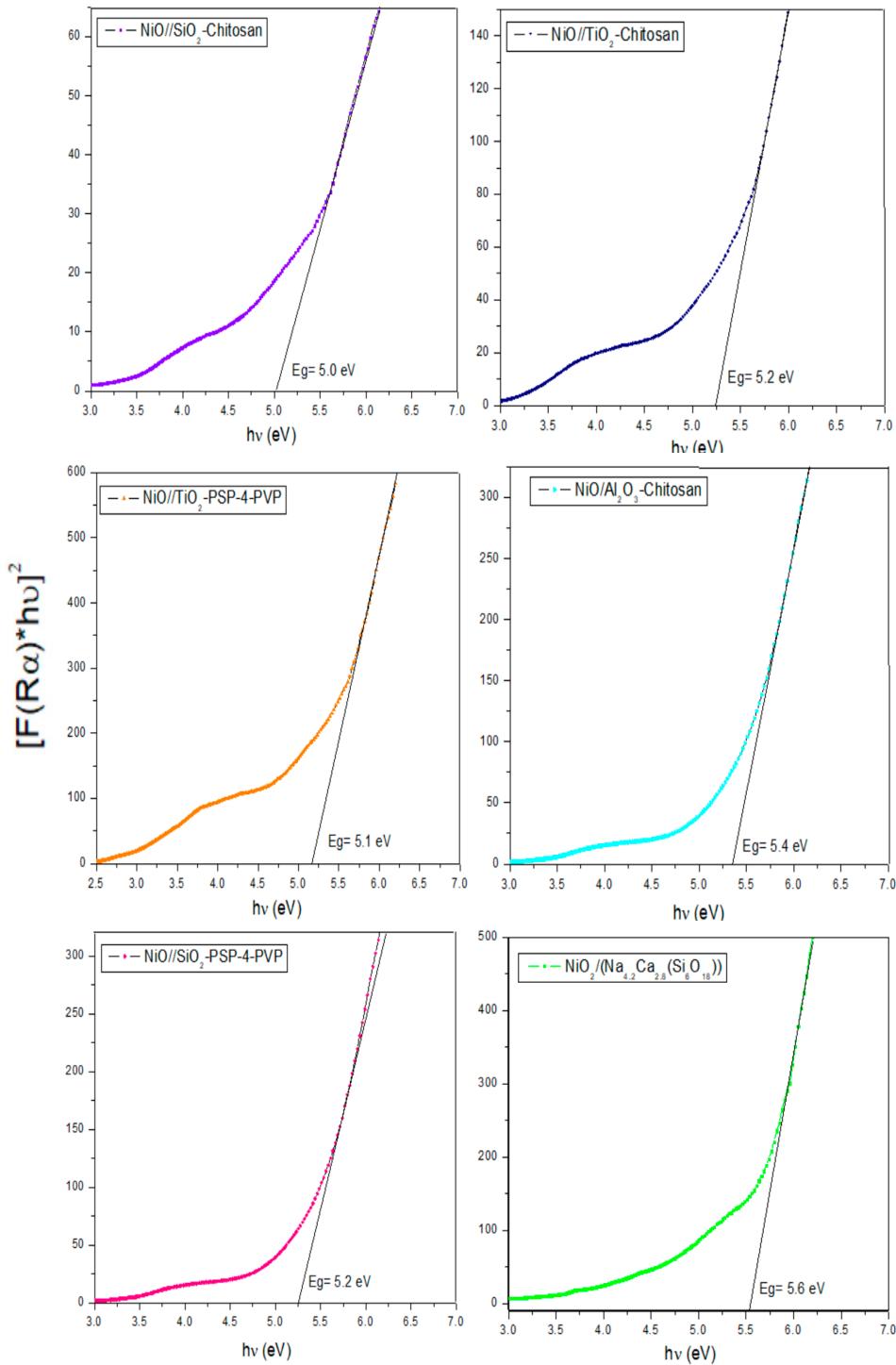
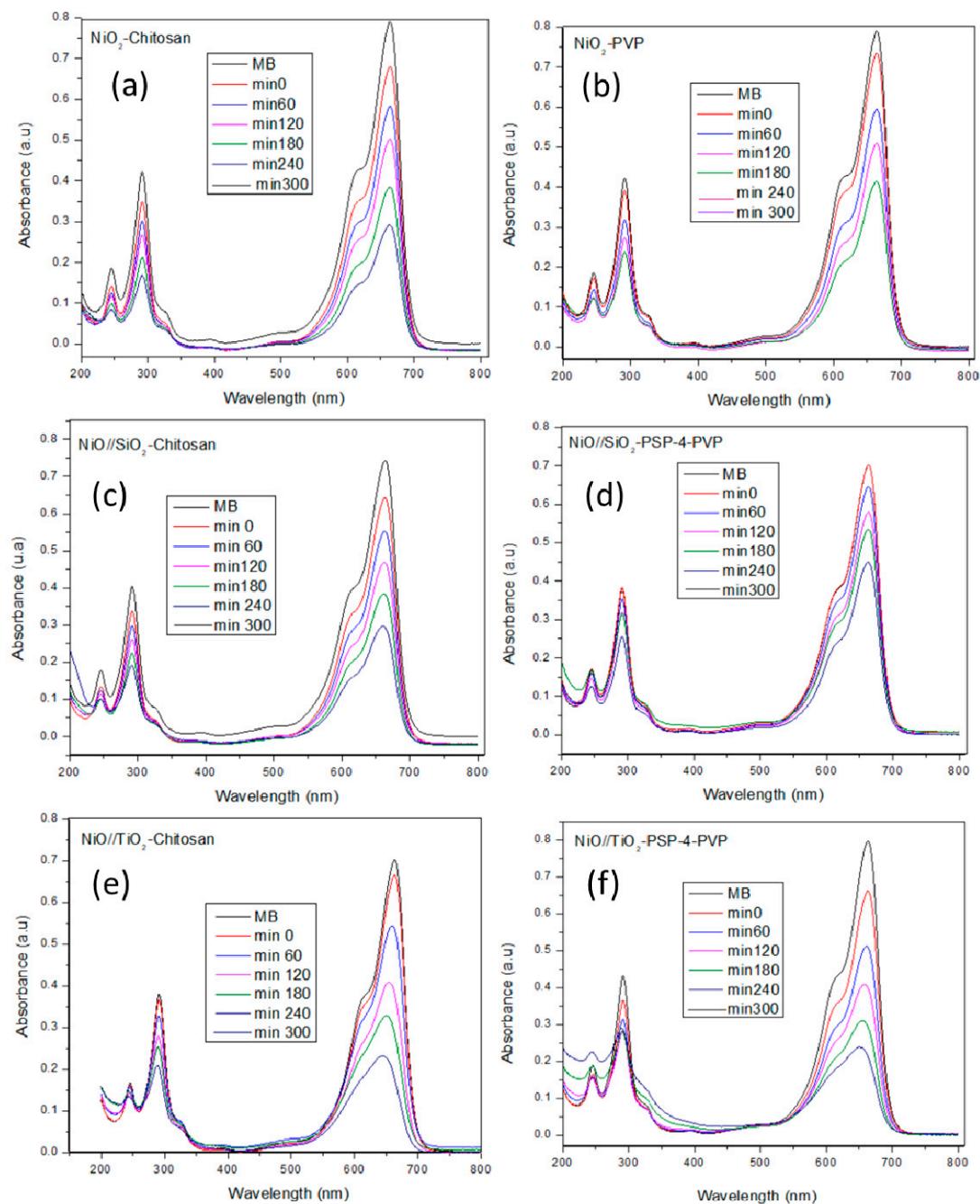


Figure S5. Tauc determination of E_g values for NiO from Chitosan-(NiCl₂)n. and PS-co-4-PVP-(NiCl₂)n and for NiO/SiO₂, NiO/TiO₂, NiO/Al₂O₃ and NiO/Na_{4.2} Ca_{2.8}(Si₆ O₁₈) composites.



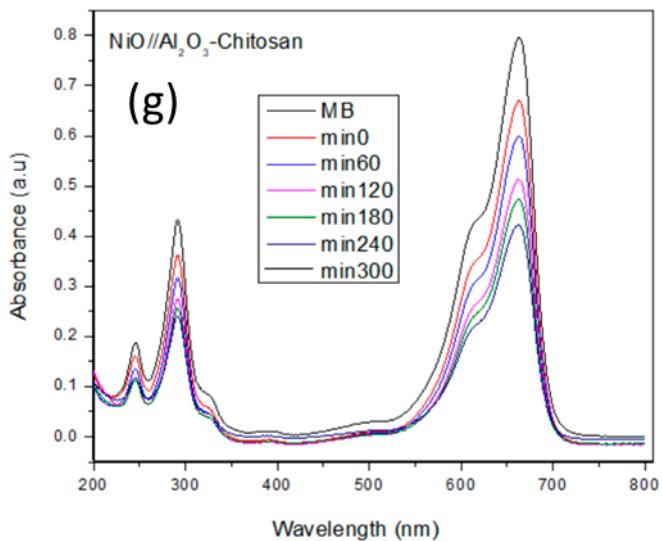


Figure S6. Absorbance vs time for the blue methylene degradation for NiO (**a**) and for the composites NiO/SiO₂, NiO/TiO₂, NiO/Al₂O₃; (**b**) NiO/SiO₂ from Chitosan·(NiCl₂)_x//TiO₂; (**c**) NiO/SiO₂ from PS-co-4-PVP·(NiCl₂)_x//TiO₂; (**d**) NiO/TiO₂ from Chitosan·(NiCl₂)_x//TiO₂; (**e**) NiO/TiO₂ from PS-co-4-PVP·(NiCl₂)_x//TiO₂; (**f**) NiO/Al₂O₃ from Chitosan (NiCl₂)_x//Al₂O₃; (**g**) NiO/ Na_{4.2}Ca_{2.8}(Si₆O₁₈) from Chitosan·(NiCl₂)_x// Na₂O·CaO·SiO₂

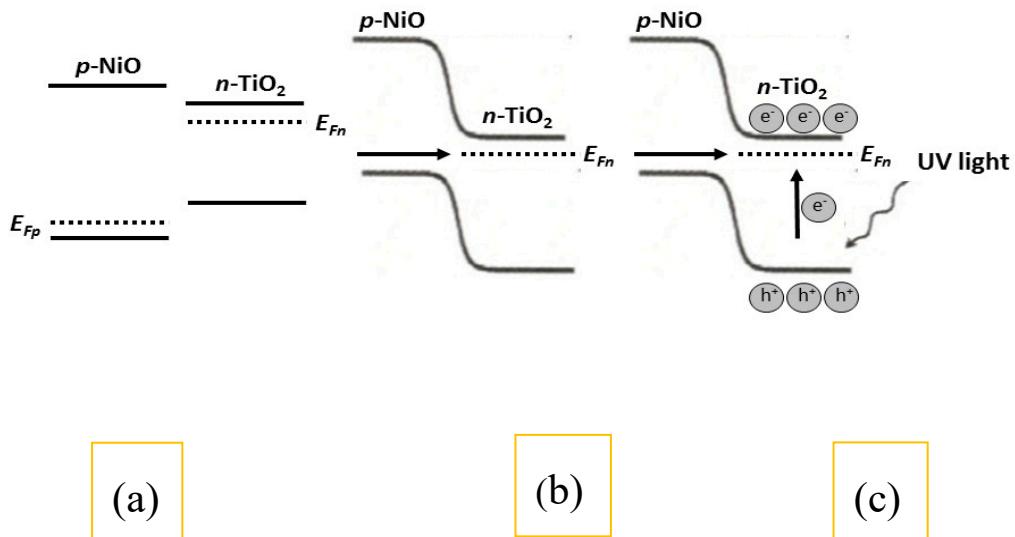


Figure S7. Schematic diagrams for (a) energy bands of p-NiO and TiO₂ before contact, (b) formation of p-n junction and its energy diagram at equilibrium and (c) transfer of holes from n-TiO₂ to p-NiO under UV irradiation.

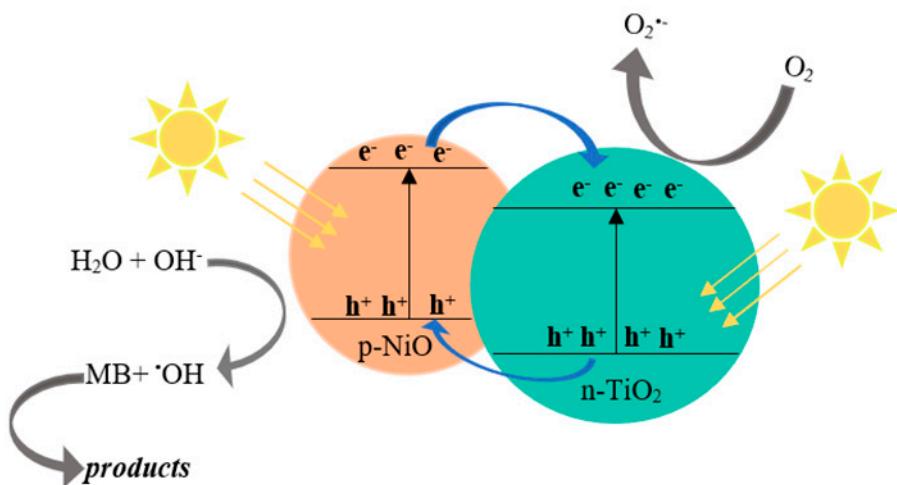


Figure S8. The photodegradation mechanism of NiO/TiO₂ composites.

When NiO-TiO₂ nanocomposites are illuminated by visible light, the electrons of the Ni 3d sub-band are excited and transferred to the conduction band (see figure S11 in supplementary information). Accordingly, a high flux of free electrons is produced in the conduction band of TiO₂. The photogenerated electrons in the conduction band of TiO₂ reduce O₂ species to O²⁻. This pathway is crucial to promote the photocatalytic efficiency in the MB oxidative decomposition. Then, the photoinduced holes (h⁺) in the valence bond of TiO₂ are moved to the valence bond of NiO, generating a high flow of holes at the NiO interface. These holes react with H₂O or OH⁻ ions, producing extremely oxidative OH radicals, which proper oxidants in the photocatalytic oxidation process. These radicals react rapidly with methylene blue.

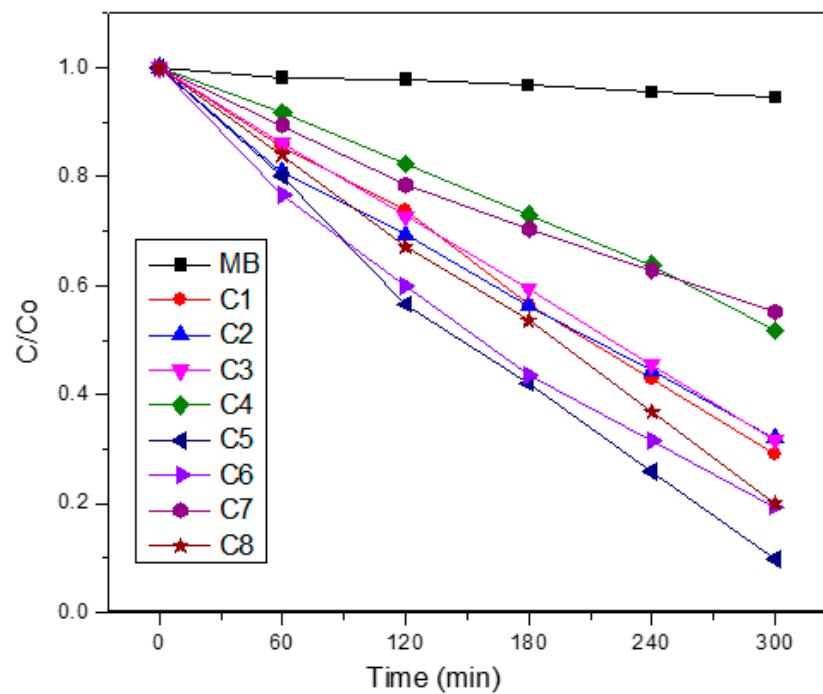


Figure S9. Kinetic plot of the blue methylene degradation with the composites NiO/SiO₂, NiO/TiO₂, NiO/Al₂O₃ and NiO/Na_{4.2}Ca_{2.8}(Si₆O₁₈).

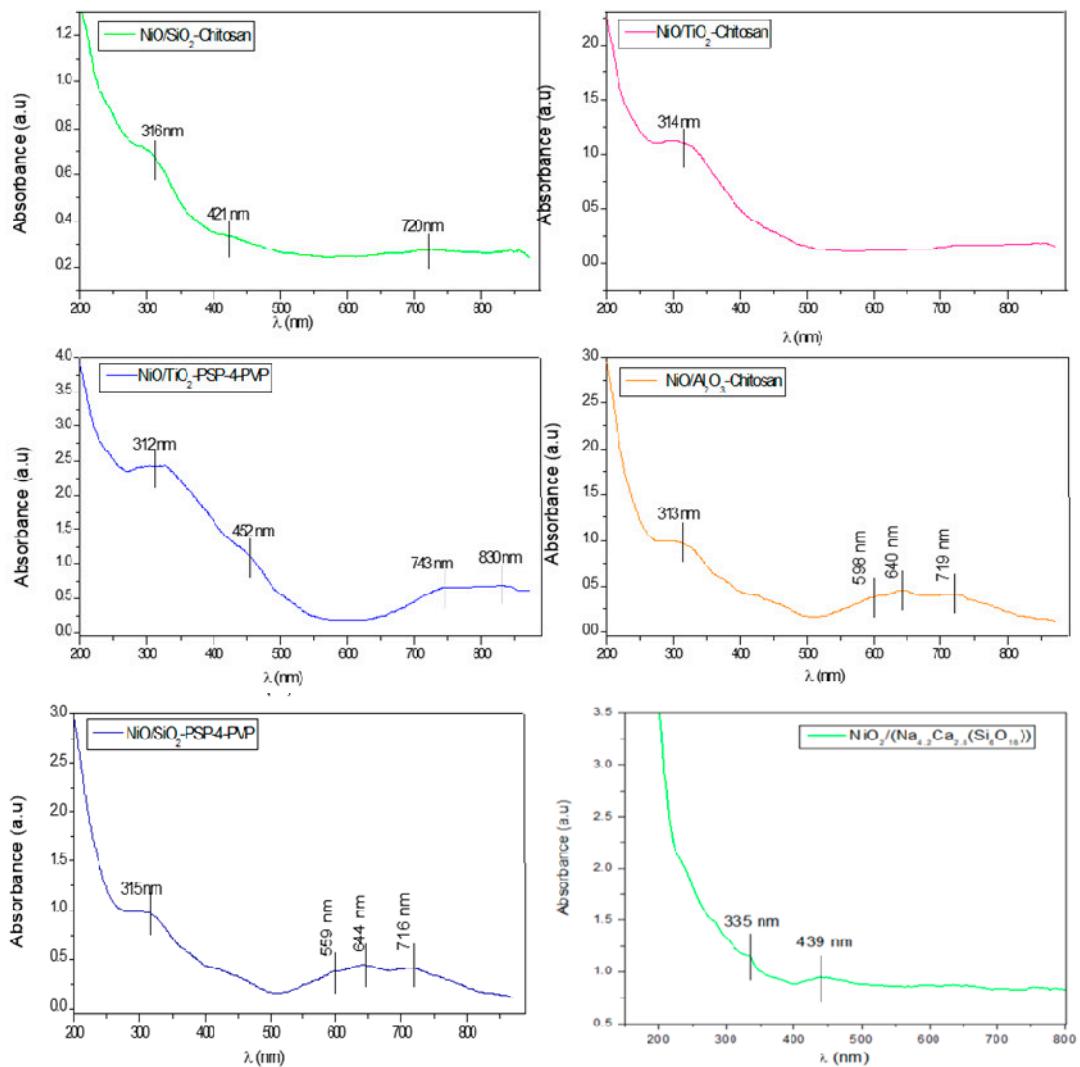


Figure S10. UV-Vis absorption spectra of the composites.

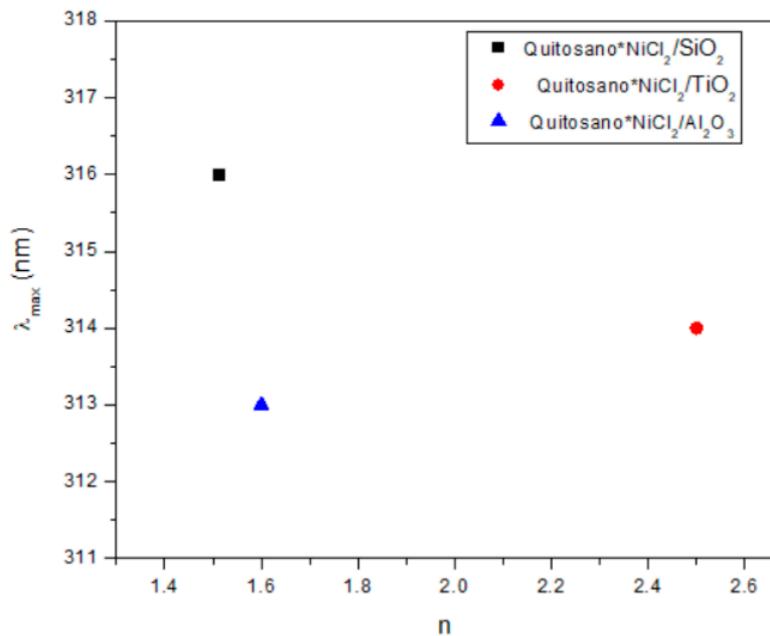


Figure S11. Plot of λ_{\max} for the NiO vs the refractive index for the matrices SiO_2 , TiO_2 and Al_2O_3 .